

INFRARED DETECTOR WITH AMORPHOUS
SILICON DETECTOR ELEMENTS, AND A METHOD
OF MAKING IT

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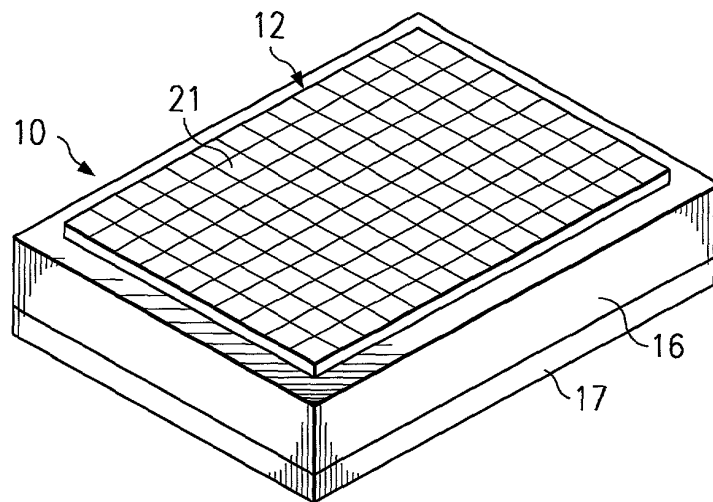


FIG. 1

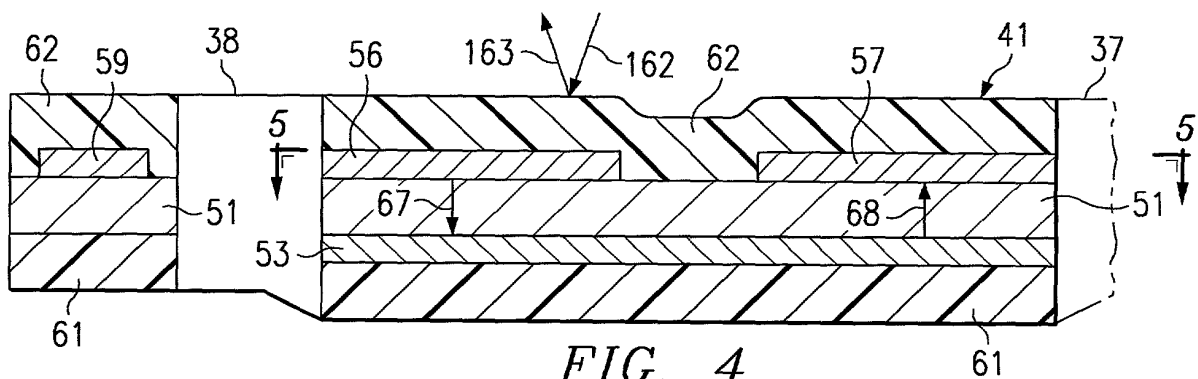


FIG. 4

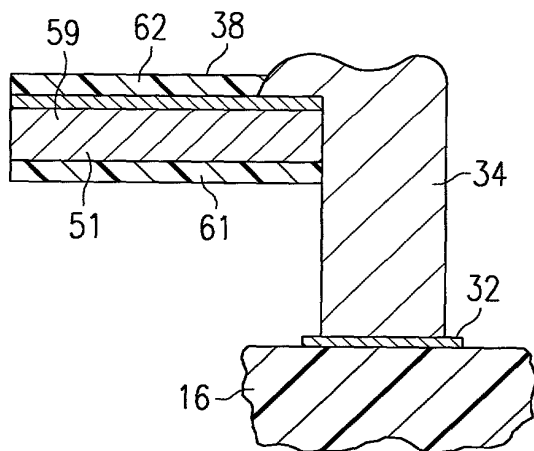


FIG. 3

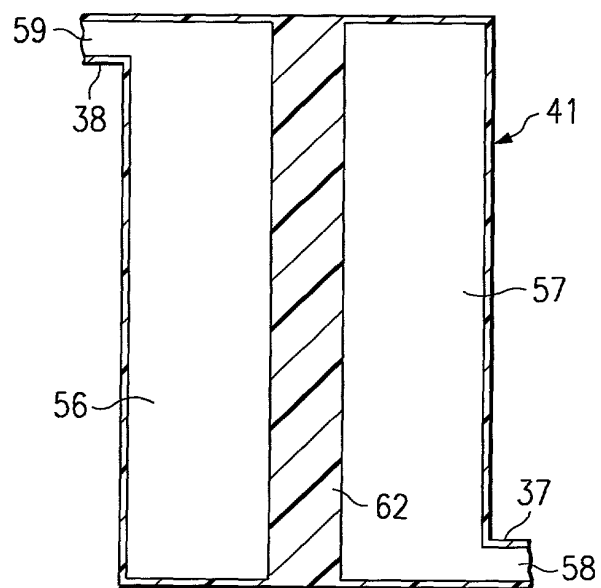


FIG. 5

FIG. 2

